

# MSEC 2025 NAMRC 53

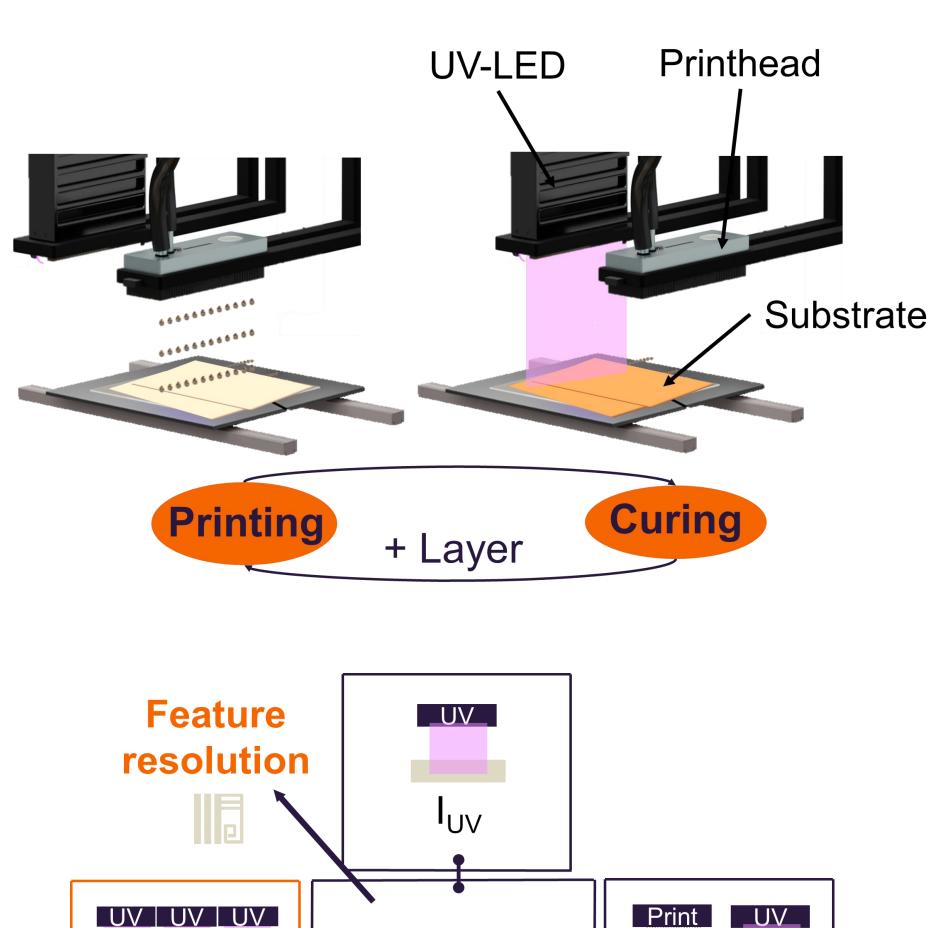
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## THE IMPACT OF SUBSTRATE COLOR ON FEATURE RESOLUTION IN 3D INKJET PRINTING

### INTRODUCTION



**Droplet** 

Coalescence

\_UV\_

**L**print-curing

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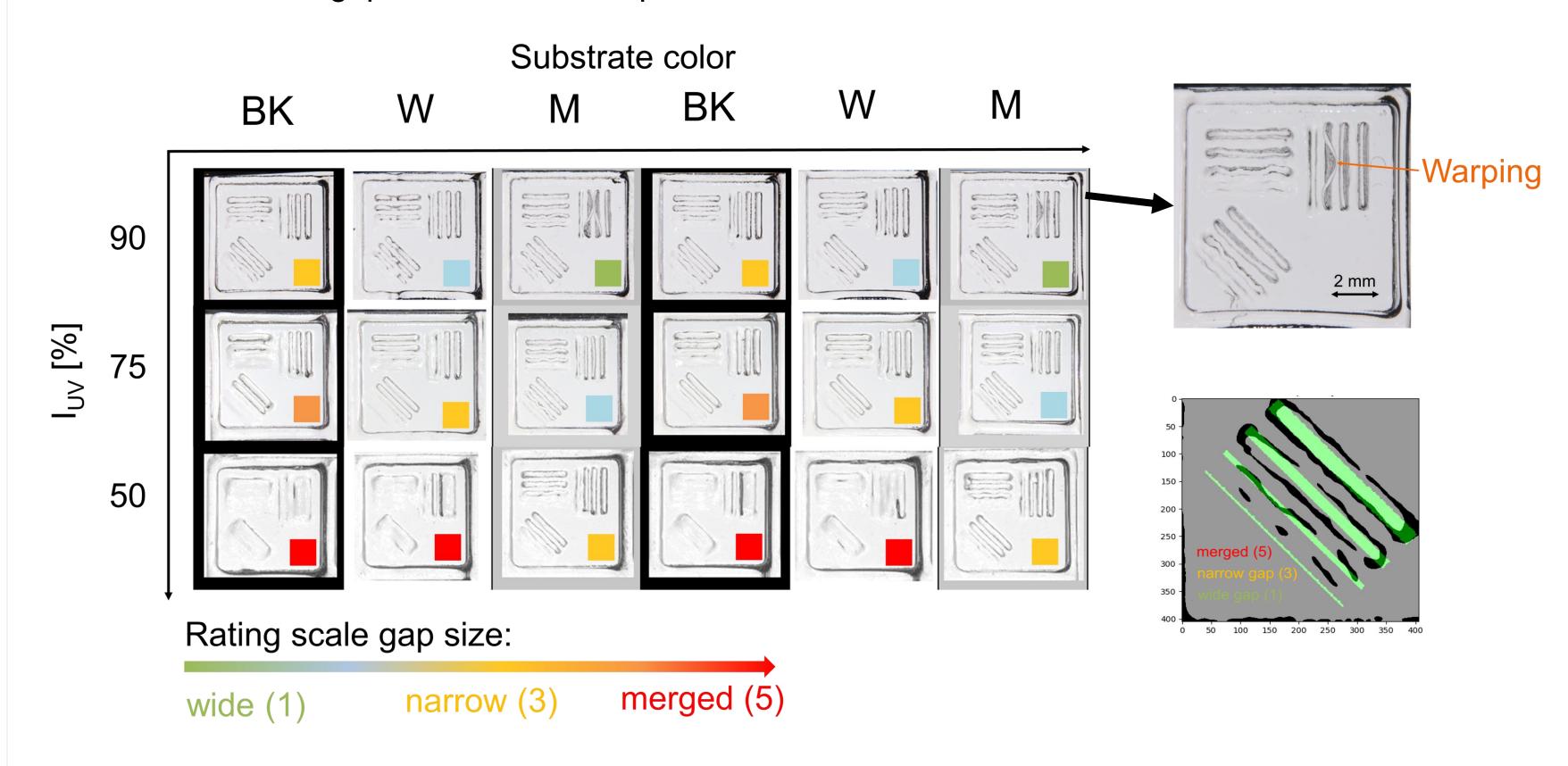
### **A**BSTRACT

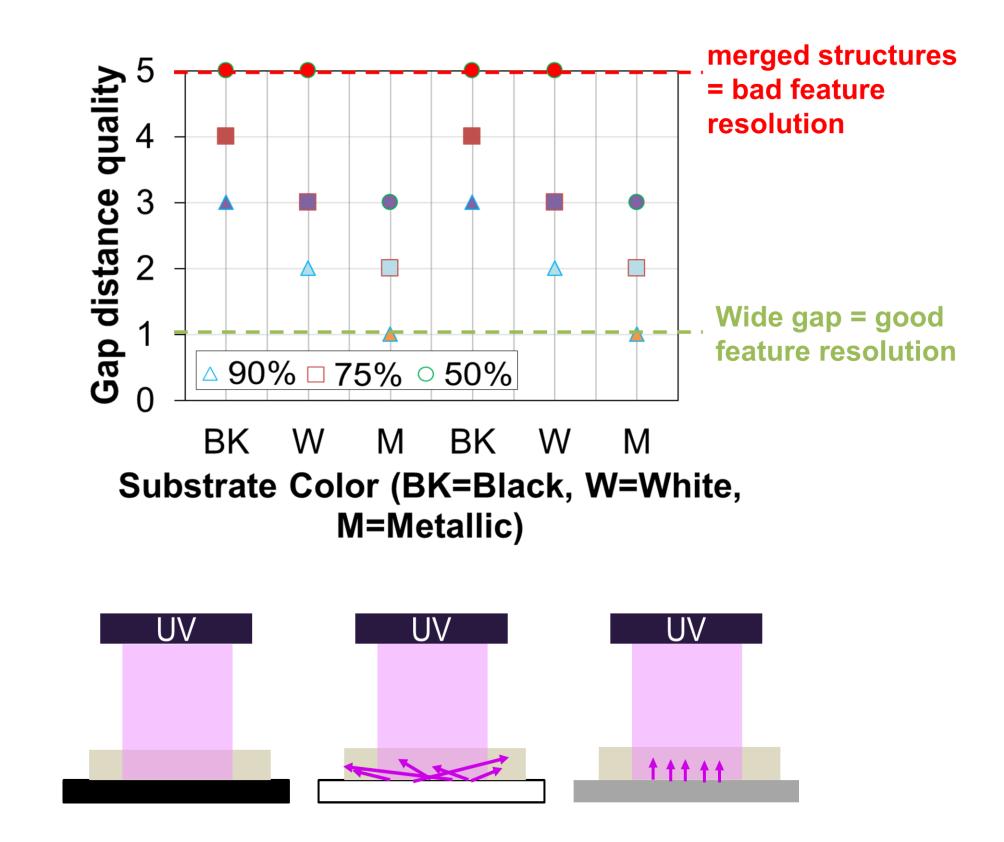
3D inkjet printing is an additive manufacturing technology that generates 3D objects layer by layer by printing thousands of droplets. The process involves multiple sub-processes, such as printing and curing which requires a close process control in order to achieve high accuracy. Specifically, the curing of the printed layer has been shown to influence feature resolution, as curing settings determine the coalescence behavior between adjacent droplets. The objective of this study is to investigate whether the color of the substrate significantly affects feature resolution. A transparent UV-sensitive ink is used to print a 3D object consisting of multiple thin walls with 3 different UV intensities (50%, 75% and 90%) on a substrate with 3 different colors (black, white and metallic). This study confirms that the substrate color has a considerably effect on the feature resolution as the UV-radiation transmit through the transparent layer. In the case of white and metallic color, the reflected UV-radiation cures the printed layer additionally and improves the feature resolution.

### **RESULTS & DISCUSSION**

Criteria for the quality of the feature resolution is the **gap distances** between the structures. A wider gap size indicates improvement of the feature resolution.

Gap between elements changes in dependence of substrate color and UV-intensity. The droplets spreads less when the substrate color is changed from black to white to metallic surface. This behavior is evident for all UV-intensities.





### REFERENCES

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- [2] Chen KJ, Elkaseer A, Scholz SG, Hagenmeyer V. On the correlation between pre-processing workflow and dimensional accuracy of 3D printed parts in high-precision Material Jetting. Additive Manufacturing. 2024;91.
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# DESIGN Unit: pixel [px] 1 px = 1 in/1800 dpi = 5e-4 in (14.11 µm) Print resolution: 1800 dpi Layer thickness: 158 µm (19 layers) UV-curing exposure time: 200 ms UV-curing intensity: 50/75/90% Substrate Printed specimen

### CONCLUSION

- The impact of different substrate color on the resulting feature resolution is evident for a 3D object printed from a transparent ink and with a layer thickness of ~150 µm.
- Adjusting substrate color or color of the ink can improve the achievable accuracy of the printed feature without increasing the UV-source settings.
- The improvement utilizes the reflective property of the substrate which facilitates additional curing of the printed layer from the bottom.
- Higher degree of curing decelerates the droplet spreading, and smaller droplets and higher accuracy can be achieved.
- In multi-material printing, different UV-light interaction behavior might require
  a complex control of the curing condition to ensure consistent curing result.

### **ACKNOWLEDGEMENT**

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